# COMPLEX PHOTONIC SYSTEMS FOR VOLUME MANUFACTURING

Solutions to overcome challenges in Optical Design, Assembly & Industrialization

Simon Schwinger February 3, 2020





### OUR VISION

To be the most technologically advanced and trusted manufacturing solutions provider

### JABIL

**Our Company** 

50+ Years of Innovation \$25.3B

FY19 Revenue

200k **Employees** 

100+

52M Square Feet Manufacturing

**Our Markets** 



**Packaging** 













Transportation





Defense & Aerospace

**Our Reach** 

DESIGN



DEVELOP MANUFACTURE



DELIVER

**Our Approach** 



**Empowered Experts** 



Innovation **Acceleration** 





Manufacturing **Agility** 



**Supply Chain Orchestration** 

**Our Difference** 

**Global Operational** Excellence

**Workcell Model** 

**Sustainability** 

**Supply Chain Intelligence & Agility** 

**Deep Technical Expertise** 

Stable & Tenured **Management Team** 

**Process Innovation** 

**Distributed Manufacturing** 

Integrity, Ingenuity & Innovation

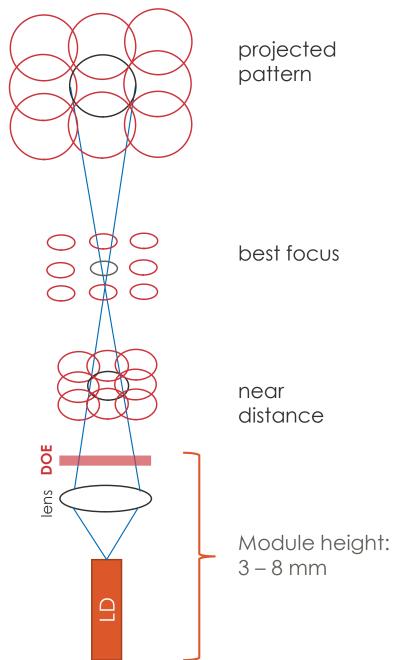




# DOT PROJECTOR: CONFIGURATION

Parameter	Value	
Wave length	IR 940nm	
Focus distance	0.2m – 1.2m	
Grid pitch	320 x 180	
FoV	63° x 35,5°	
LD	TO38:Ø 3.8mm / height ~3.3mm COS: 0.225 x 1 x 0.14 mm³	
Focal length	2.2mm	
Divergence fast axis	17°±3°	
Divergence slow axis	8°±3°	
TOL focus without AA	30µm	
Shift emitter point	80µm	



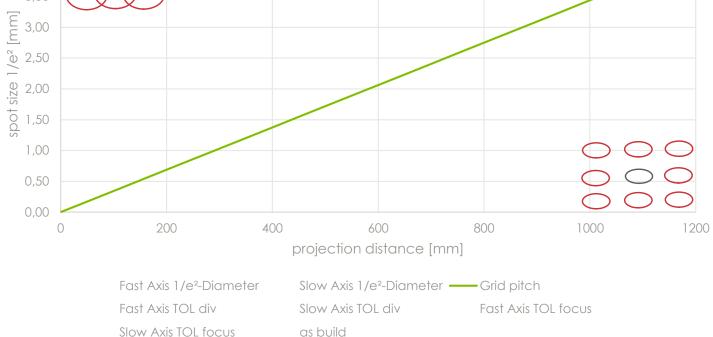


## DOT PROJECTOR: GRID PITCH



Parameter	Value	
Wave length	IR 940nm	
Focus distance	0.2m – 1.2m	
Grid pitch	320 x 180	
FoV	63° x 35.5°	
LD	TO38:Ø 3.8mm / height ~3.3mm COS: 0.225 x 1 x 0.14 mm³	
Focal length	2.2mm	
Divergence fast axis	17°±3°	
Divergence slow axis	8°±3°	
TOL focus without AA	30µm	
Shift emitter point	80µm	

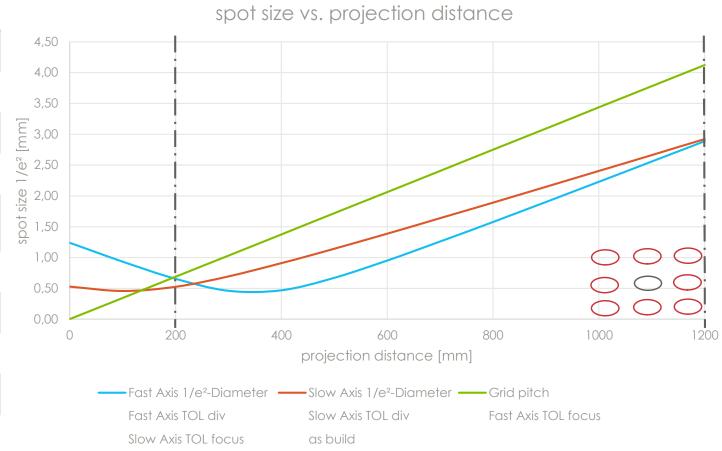
# spot size vs. projection distance 4,50 4,00 3,50 3,00



## DOT PROJECTOR: FOCAL LENGTH



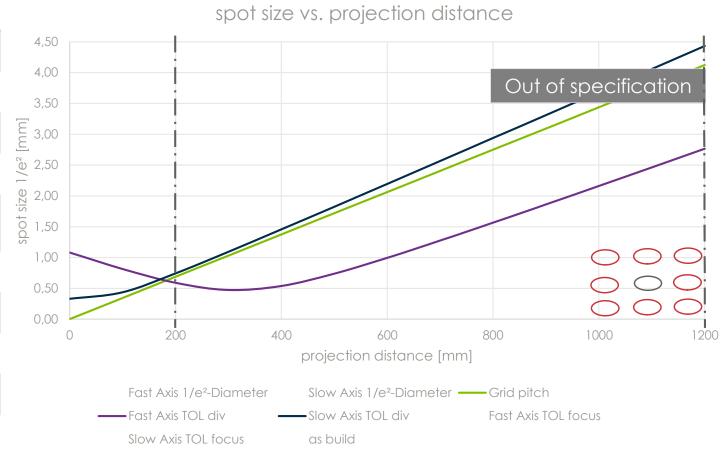
Parameter	Value	
Wave length	IR 940nm	
Focus distance	0.2m – 1.2m	
Grid pitch	320 x 180	
FoV	63° x 35.5°	
LD	TO38:Ø 3.8mm / height ~3.3mm COS: 0.225 x 1 x 0.14 mm³	
Focal length	2.2mm	
Divergence fast axis	1 <b>7°</b> ±3°	
Divergence slow axis	8°±3°	
TOL focus without AA	30µm	
Shift emitter point	80µm	



### DOT PROJECTOR: TOLERANCE DIVERGENCE



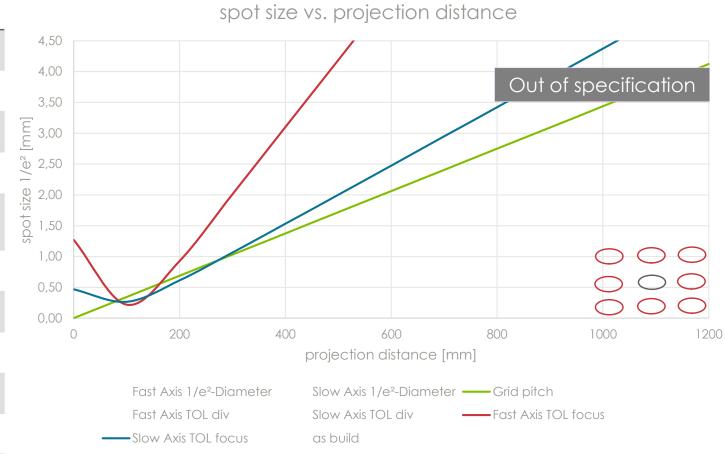
Parameter	Value	
Wave length	IR 940nm	
Focus distance	0.2m - 1.2m	
Grid pitch	320 x 180	
FoV	63° x 35.5°	
LD	TO38:Ø 3.8mm / height ~3.3mm COS: 0.225 x 1 x 0.14 mm³	
Focal length	2.2mm	
Divergence fast axis	17° <b>±3°</b>	
Divergence slow axis	8°±3°	
TOL focus without AA	30µm	
Shift emitter point	80µm	



### DOT PROJECTOR: TOLERANCE FOCUS WITHOUT ACTIVE ALIGNMENT

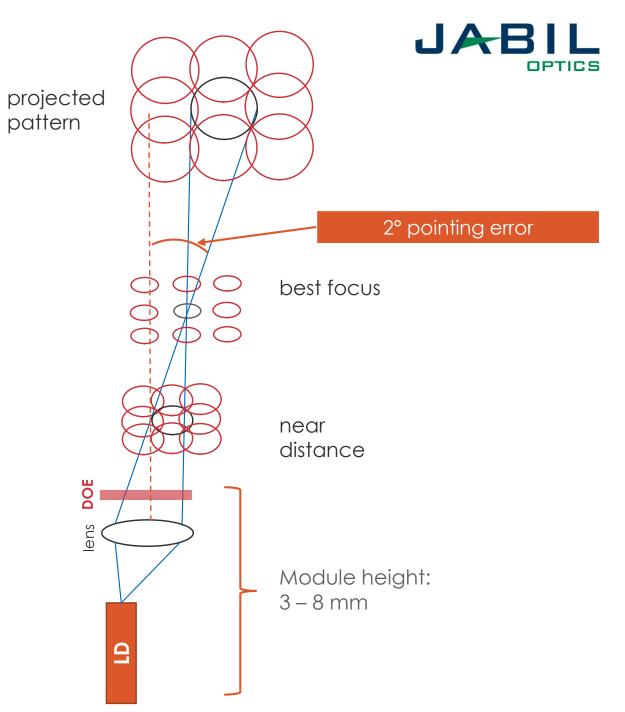


Parameter	Value	
Wave length	IR 940nm	
Focus distance	0.2m - 1.2m	
Grid pitch	320 x 180	
FoV	63° x 35.5°	
LD	TO38:Ø 3.8mm / height ~3.3mm COS: 0.225 x 1 x 0.14 mm³	
Focal length	2.2mm	
Divergence fast axis	17°±3°	
Divergence slow axis	8°±3°	
TOL focus without AA	30µm	
Shift emitter point	80µm	



# DOT PROJECTOR: SHIFT LD

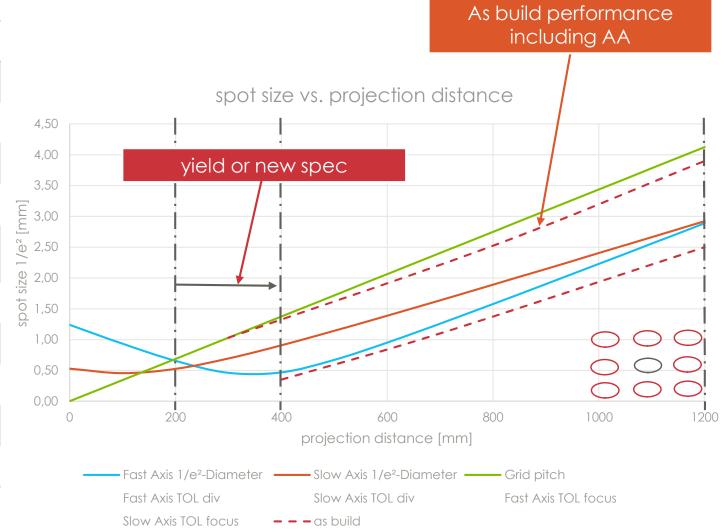
Parameter	Value	
Wave length	IR 940nm	
Focus distance	0.2m - 1.2m	
Grid pitch	320 x 180	
FoV	63° x 35.5°	
LD	TO38:Ø 3.8mm / height ~3.3mm COS: 0.225 x 1 x 0.14 mm³	
Focal length	2.2mm	
Divergence fast axis	17°±3°	
Divergence slow axis	8°±3°	
TOL focus without AA	30µm	
Shift emitter point	80µm	



### DOT PROJECTOR: AS BUILD PERFORMANCE



Parameter	Value	
Wave length	IR 940nm	
Focus distance	0.2m – 1.2m	
Grid pitch	320 x 180	
FoV	63° x 35.5°	
LD	TO38:Ø 3.8mm / height ~3.3mm COS: 0.225 x 1 x 0.14 mm³	
Focal length	2.2mm	
Divergence fast axis	17°±3°	
Divergence slow axis	8°±3°	
TOL focus without AA	30µm	
Shift emitter point	80µm	





### ACTIVE ALIGNMENT (AA) FOR LIDAR & 3D SENSING USING PIXID PLATFORM





#### USE CASES

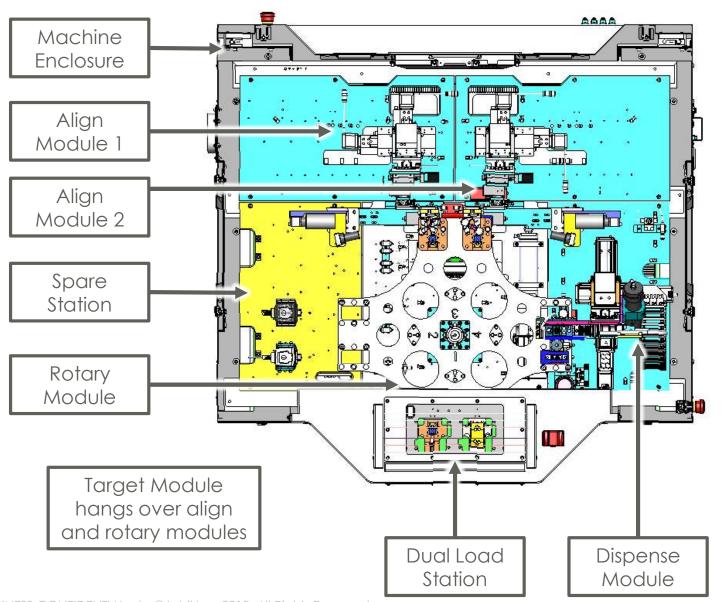
- Lens collimation
- Receiver alignment
- Structured light projection alignment
- Camera lens alignment for structured light inspection
- Module to module relative pointing (tip, tilt, rotation)
- Module to module baseline distance setting (XY)

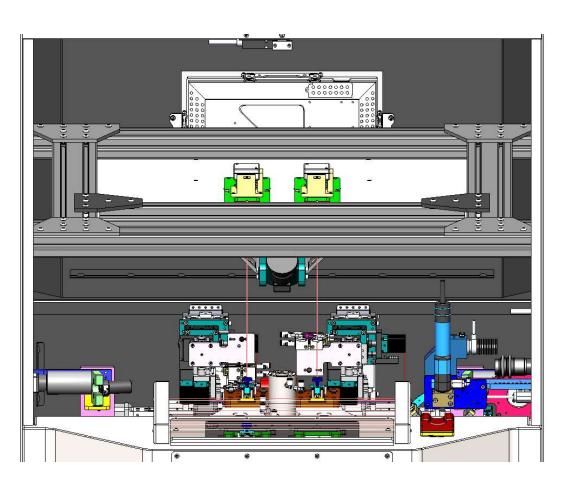
#### **FFATURES**

- Single or dual head 6 axis Active Alignment
  - 0.2um linear resolution
  - 0.01 deg angular resolution
- Automated adhesive dispense with post dispense inspection for quality control
- Customized AA feedback systems and AA algorithms
- Automated UV curing
- Systems delivered with turnkey process for high volume manufacturing

### PIXID MACHINE LAYOUT FOR DUAL HEAD LASER PROJECTION MODULE AA

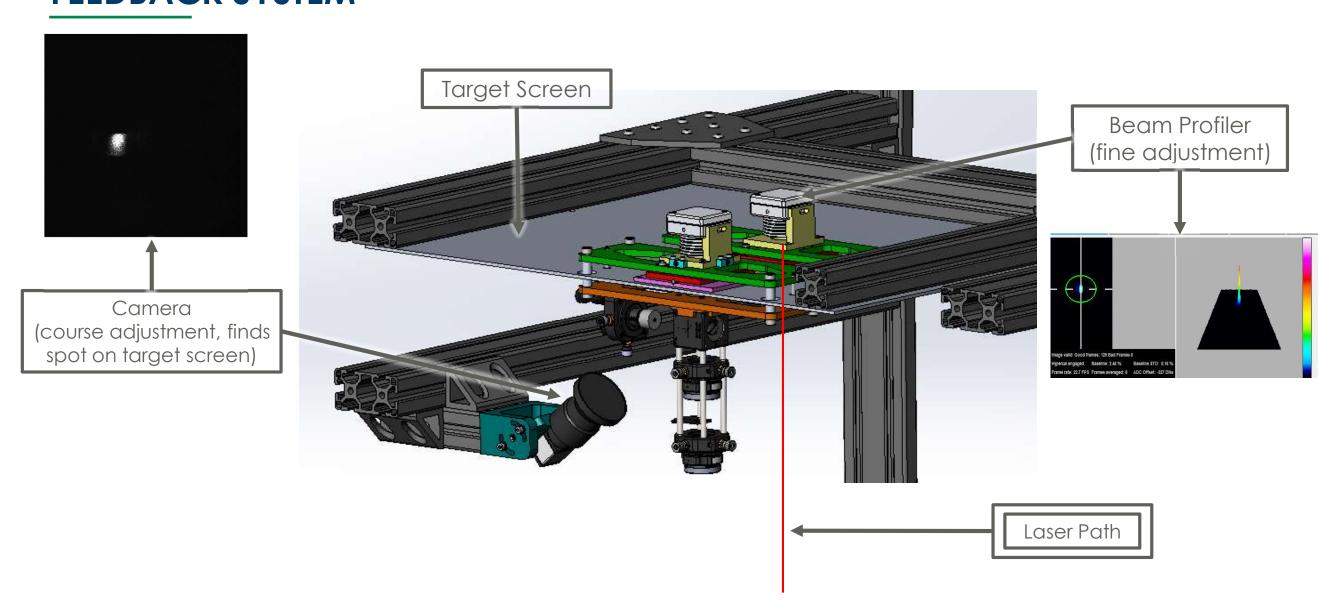






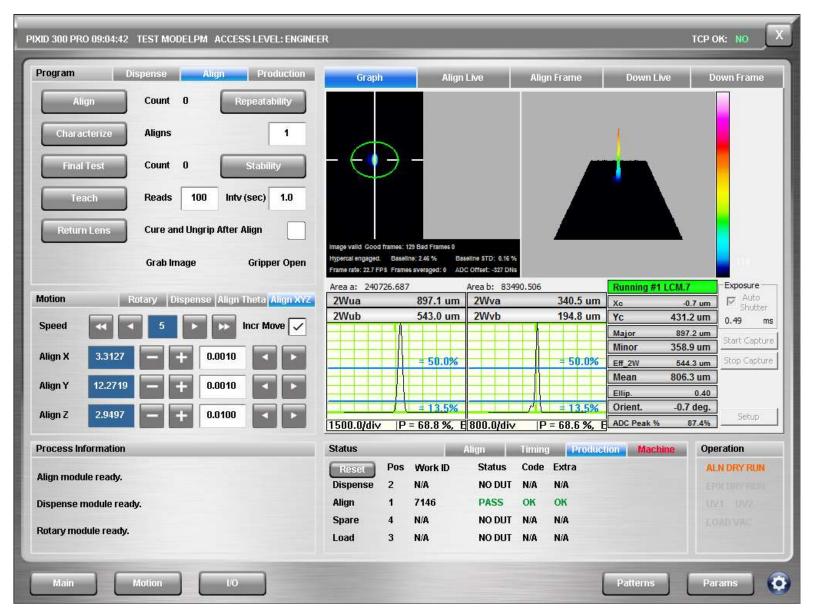
### DUAL HEAD LASER PROJECTION MODULE AA FEEDBACK SYSTEM





#### LASER COLLIMATION OPTIMIZATION





### LASER PROJECTION MODULE TESTING



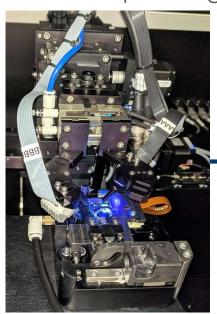




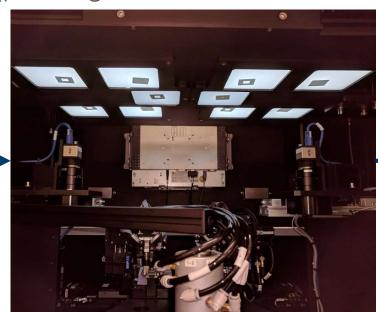
#### MODULE ASSEMBLY AND INTEGRATION FOR 3D SENSING



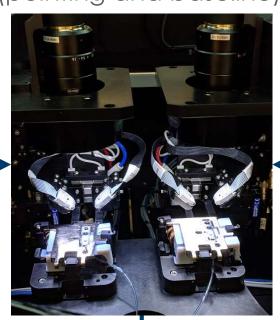
NIR/RGB CCM AA (focus and pointing)



NIR CCM to RGB CCM Alignment (pointing and baseline distance)



LPM to NIR AA (pointing and baseline)



LPM AA (collimation and XY)

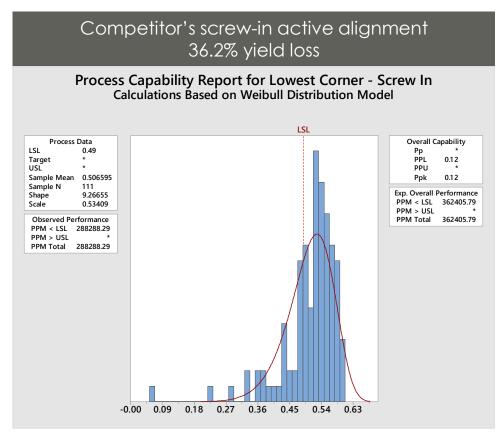


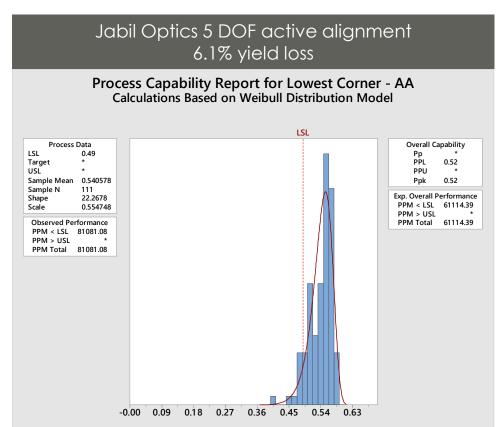
Integrated 3D Sensing Module (NIR CCM, RGB CCM, LPM)



#### **ACTIVE ALIGNMENT CAPABILITY ANALYSIS**





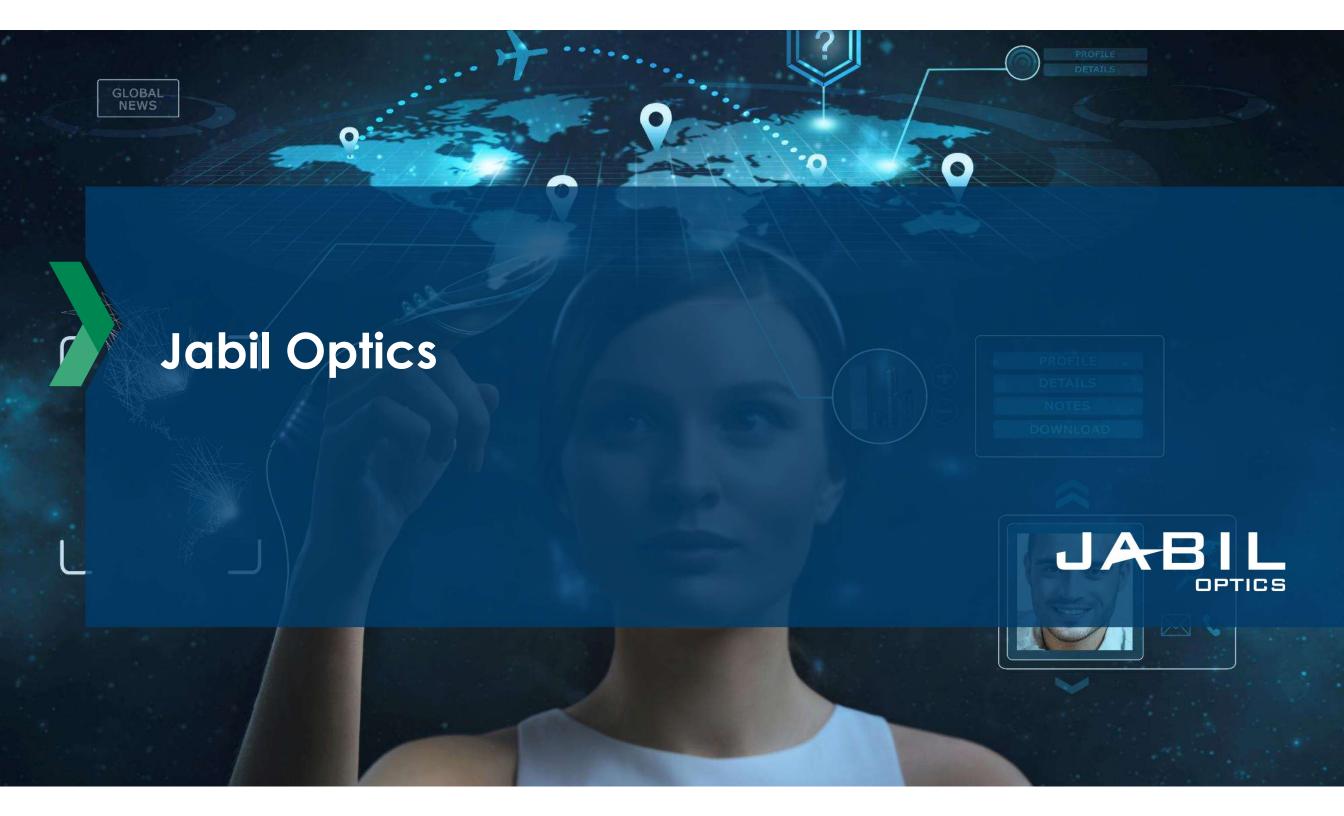


	Screw In	Jabil Optics AA
Ppk	.12	.52
PPM Defects	362,405 PPM	61,114 PPM

YIELD IMPACT CONCLUSIONS

Screw In – 36.2% Yield Loss

Jabil Optics AA – 6.1% Yield Loss



#### WHAT JABIL OPTICS CAN DO FOR YOU...

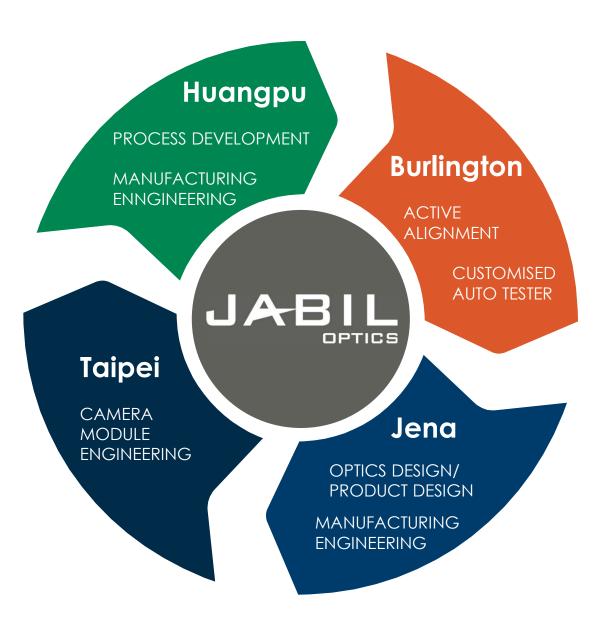


#### PROCESS DEVELOPMENT

- Advanced process solutions
- Optimal material and component selection
- Customized adhesive solutions
- Equipment guidance and selection

### MANUFACTURING ENGINEERING

- Design and procurement of optical lens assemblies and sub-assemblies
- New product introduction
- High-volume production of optical solutions
- Final goods assembly
- Test
- Pack-out



#### ACTIVE ALIGNMENT

- Active alignment
- Precision components placement
- Lens assemblies
- Gluing technologies
- · Chip-on-board, Chip-on-flex
- Chip-on-stiffener, FlipChip
- Wire-bonding and ACF bonding
- Assembly automation

#### PRODUCT DESIGN

- World class optics design
- Electrical engineering
- Design for high-volume manufacturing
- Design to cost

### WHAT YOU CAN DO FOR JABIL OPTICS...



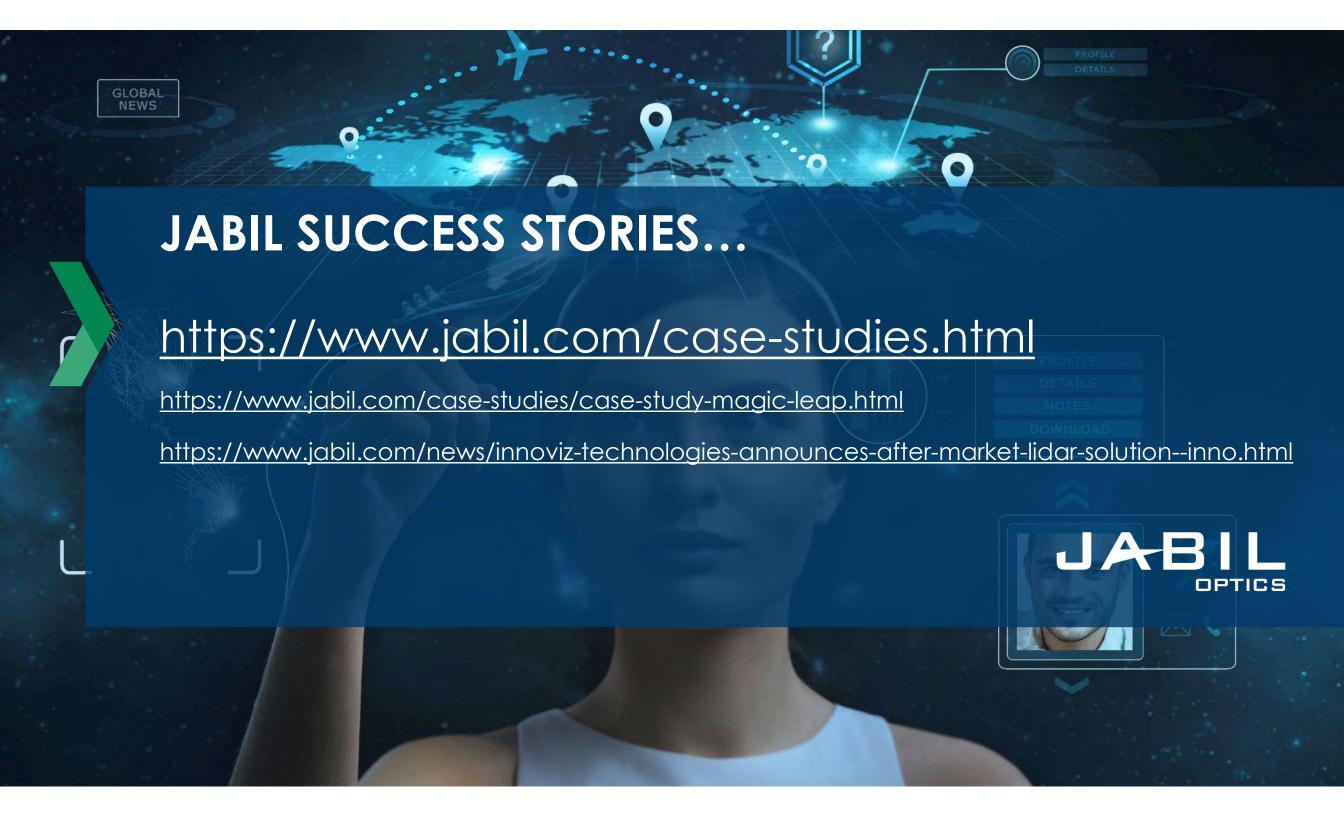
Enable cutting edge technologies

Have strong brands

Fund innovative products

Seek a strong manufacturing partner





### THANK YOU





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# This presentation was presented at EPIC World Photonics Technology Summit 2020

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